

DOCKET NO.: 3905 #21/IDS

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
 IN THE MATTER OF THE PATENT APPLICATION

OF: Takao NAKAMURA et al.

ART UNIT: 2814

SERIAL NO.: 09/519,408

EX.: W. Louie

ORIGINAL APP. FILED: March 3, 2000

CONFIRMATION NO. 7245

CPA FILED: March 18, 2002

FOR: Semiconductor Light-emitting Device,
 Method of Manufacturing Transparent
 Conductor Film and Method of Manu-
 facturing Compound Semiconductor
 Light-emitting Device

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JUN 18 2002

June 18, 2002

TECHNOLOGY CENTER 2800

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97(b) AND
M.P.E.P. 201.06(d) WITH CERTIFICATE OF MAILING ON LAST PAGE

Dear Sir:

- 1) Pursuant to 37 C.F.R. §§ 1.56, 1.97 and 1.98 applicants enclose a Fourth Form PTO-1449 and copies of the references cited thereon. A copy of ~~an English translation of~~ a Japanese Office Action issued in the counterpart Japanese Priority Application 11-181414 on March 19, 2002 is also enclosed. Applicants request that the references be made of record herein.
- 2) This Information Disclosure Statement is being filed before the issuance of a first Office Action on the merits in this Continued Prosecution Application (CPA) that was filed on March 18, 2002. Thus, this IDS does not require a fee and shall be considered by the Examiner in accordance with M.P.E.P. §201.06(d).
- 3) References AH and AV to AB2 are in English. References AE, AG, AI to AU are each accompanied by an English Abstract. Reference AF is accompanied by a partial English translation. Reference AK corresponds to AH from which its relevance can be determined

in English. Therefore, no further discussion of the references is required.

- 4) For a discussion of the relevance of the references, please see the corresponding remarks included in the Voluntary Amendment filed by telefax on June 18, 2002, which remarks are incorporated herein by reference.
- 5) Enclosed herewith is a translation of the Japanese Office Action issued on March 19, 2002 in the counterpart Japanese Priority Application 11-181414. This English translation shows why the Japanese Examiner found the cited references to be relevant. The Japanese Examiner's discussion of the references is not adopted or ratified as accurate by the applicant, but is merely submitted for the U. S. Examiner's consideration.
- 6) Applicants respectfully request that the Examiner consider all references of record, return an initialled copy of the enclosed Form PTO-1449 to the applicants and ensure that all references of record are printed on any patent issuing from this application.
- 5) Favorable consideration and allowance of claims 16 to 22 are respectfully requested.

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Respectfully submitted,

JUN 18 2002

Takao NAKAMURA et al.
Applicant

By

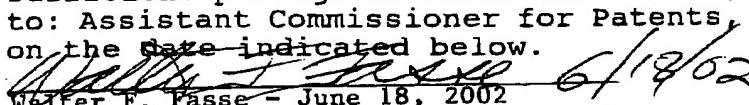

Walter F. Fasse
Patent Attorney
Reg. No.: 36132
Tel. No.: 207-862-4671
Fax. No.: 207-862-4681
P. O. Box 726
Hampden, ME 04444-0726

WFF:ar/3905
Enclosure: postcard,
Fourth Form PTO-1449 (2 sheets),
24 references, copy of Japanese
Office Action (English translation)

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CERTIFICATE OF MAILING:

I hereby certify that this correspondence with all indicated enclosures is being deposited with the U. S. Postal Service with sufficient postage as first-class mail, in an envelope addressed to: Assistant Commissioner for Patents, Washington, D. C. 20231, on the date indicated below.


Walter F. Fasse - June 18, 2002
3905/WFF:ar